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TITLE: SILICON LAYER PRODUCTION
METHOD AND SOLAR CELL
PRODUCTION METHOD
Sheet 1 of 2
Docket No.: 03500.109446.

FIG. 1A

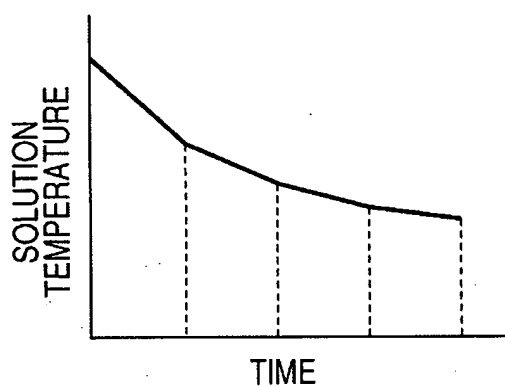


FIG. 1B

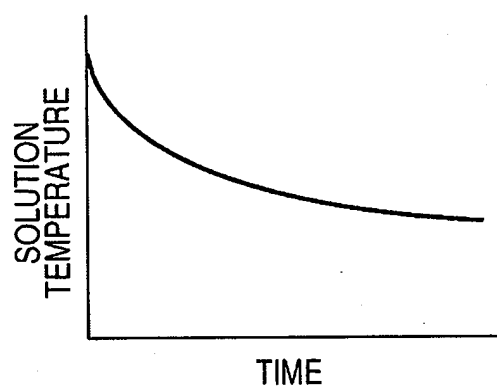


FIG. 2

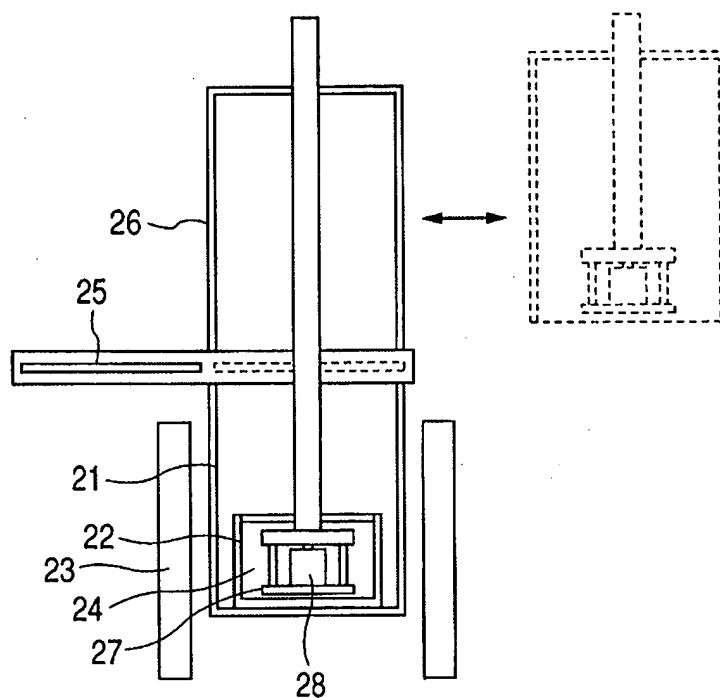


FIG. 3

